# **Towards Automatic Nanomanipulation** at the **Atomic Scale**

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### Outline

- Introduction
- System Overview
- Workpackages
  - 1. integration of nM into an STM-Measurementsystem
  - 2. segmentation/labelling of atoms and molecules
  - 3. navigation/calibration
  - 4. manipulation skills
  - 5. planning/simulation

### • Outlook



## Introduction

Definition:

Manipulation of nanometer size objects with a nanometer size tool-tip with (sub)nanometer precision.

Application: manual (scan – manipulate – scan) cycle

Motivation: Nanomanipulation will soon be a standard preparation technique for experiments in physical and biological science.

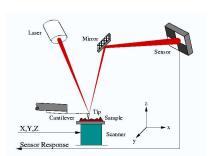
 $\Rightarrow$  automation of nanomanipulation mandatory



- Atomic Force Microscope (AFM)
  - manipulation of nanoparticles
  - push, pull, pick and place, bend, twist etc.
- Scanning Tunneling Microscope (STM)
  - manipulation at the atomic scale
  - repulsive, attractive and vertical mode

special tools integrated into a microscope

SCanning tip Tunnel current I, Tip motion





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### **STM Manipulation Modes**

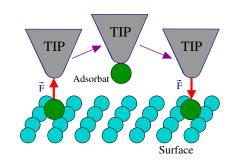
- repulsive mode (pure pushing)
  - constant current mode
- attractive mode (pure pulling)
  - constant current mode
- vertical mode

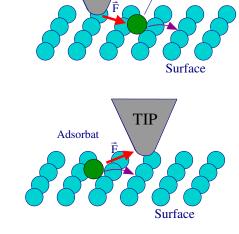
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- voltage pulse to attain atom to tip
- move in imaging mode

Technical Aspects of Multimodal Systems

- voltage pulse to attain atom to surface





TIP

Adsorbat





## **Advanced User Interfaces**

- several user interfaces intended for manual nanomanipulation under development
- features:
  - advanced graphics
  - haptic device and reliable force feedback
  - teleoperation
  - contact models, modeling of nanoobjects
  - drift compensation
- designed for ambiant AFM



- manipulating nanoparticles with an AFM
  - first steps towards automation
  - CAD-models of nanostructures
  - drift calculation

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Michigan State University

- manipulation at atomic scale with a STM
  - Autonomous Atom Assembler (AAA)
  - tool for automatic positioning of tens of single atoms
  - rule-based path planning
  - no drift compensation



National Institute of Standards and Technology

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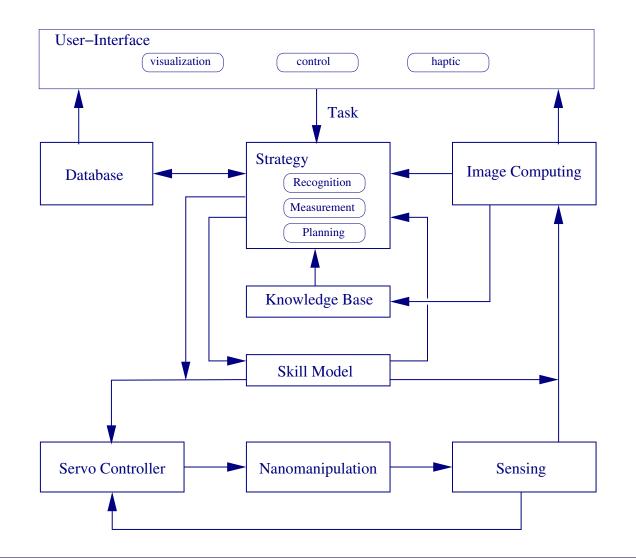
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# Automatic Manipulation of Atomic Structures in Hamburg (AMASH)

- tool for automatic nanomanipulation at atomic scale
- manual manipulation and user intervention possible anytime
- target description via graphic editor or algorithmic description
- rule-based pathplanner
- open-end knowledge base



### **System Overview**



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## Workpackages

- 1. enhanced user interface & STM
- 2. segmentation/labelling of atoms and molecules
- 3. navigation/calibration
- 4. manipulation skills
- 5. planning/simulation



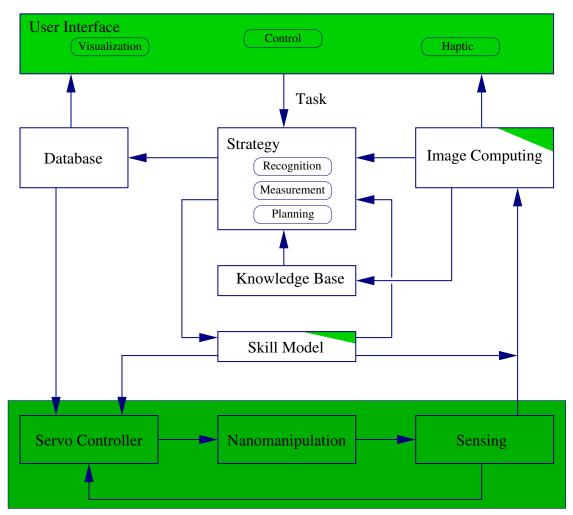
## Enhanced User Interface & AMASH

nanoManipulator from the University of North Carolinas (UNC) nanoManipulator-project:

- enhanced 3D visualization system
- haptic control system
- force-feedback-driven manual manipulation
- basic manipulation skills
- supports teleoperation
- full source code available to us



### UNC nM & AMASH



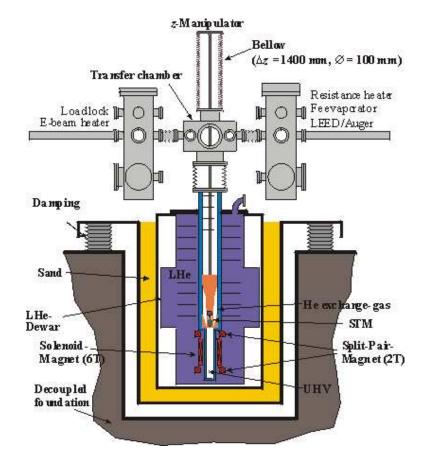
greencovered by the nanoManipulatordarkgreencovered by the microscope

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# Hamburg UHV LT-STM & AMASH

- Ultra High Vacuum (UHV)
- Low Temperature down to 6K
- Magnetic field 6T
- Contamination rate < 1 adsobate per 500x500nm per week
- Fe evaporator

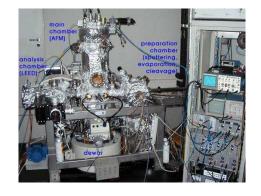






### **Measurement System**

- TOPSII measurement system from WA Technologie attached to:
  - UHV LT-STM (1)
    - \* specification see above
  - UHV LT-AFM
    - $\ast$  temperature down to 10 K
    - \* atomic resolution
  - UHV LT-STM (2)
    - $\ast\,$  temperature down to  $300\,mK$
    - \* magnetic field 14 T



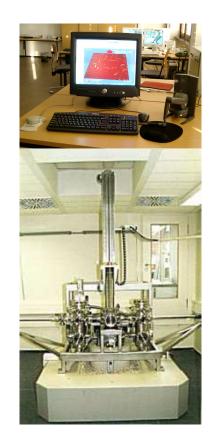


#### • full source code available

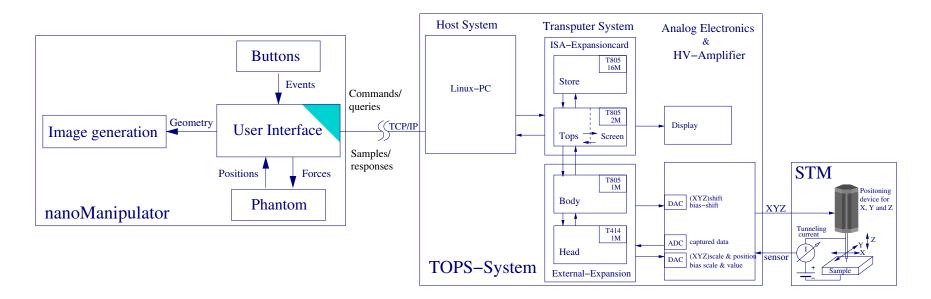
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- both user interfaces (primary and nM) should run in parallel
- at least two secondary user interfaces (nMs) should be able to run in parallel
- the architecture of the UNC nM provides an excellent basis for AMASH



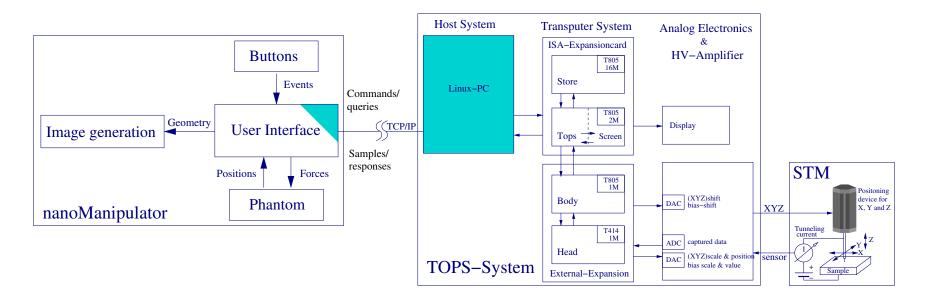
### Integration of nM & STM



• only minor changes of the nM-software

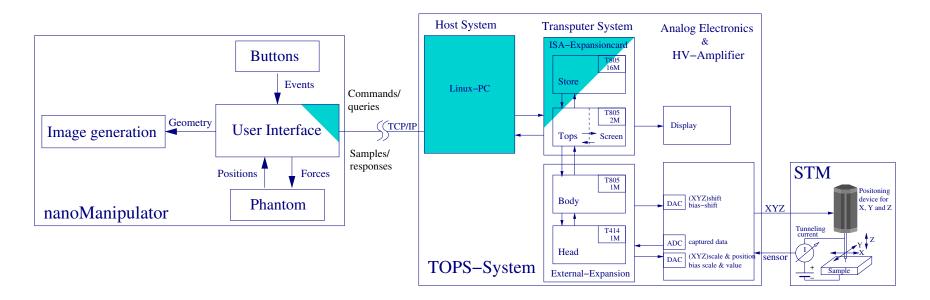


## Integration of nM & STM



- only minor changes of the nM-software
- the primary user interface of the microscope completely reprogrammed

## Integration of nM & STM



- only minor changes of the nM-software
- the primary user interface of the microscope completely reprogrammed
- some changes of the low-level routines of the measurementsystem software also neccessary

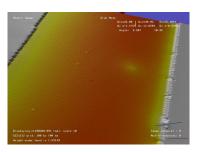
## **Requirements for primary user Interface**

- $\bullet$  interface for communication with nM via TCP/IP
- API for controlling the instrument (more flexibility with other microscopes)
- API for IEEE 488 equipment for full control of instruments environment
- script language for rapid prototyping of low-level algorithms
- ability to run instrument in batch mode
- web-interface for monitoring readouts

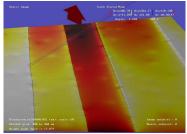


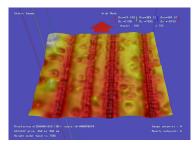
## **Results of Integration of nM & UHV LT-STM**

- full power of the nM-system is now available to the STM users
- manual manipulation is much more comfortable due to haptic device
- nM-user can access the microscope from all over the world (problem: network latency in manipulation mode)
- excellent platform for developing automation on the atomic scale

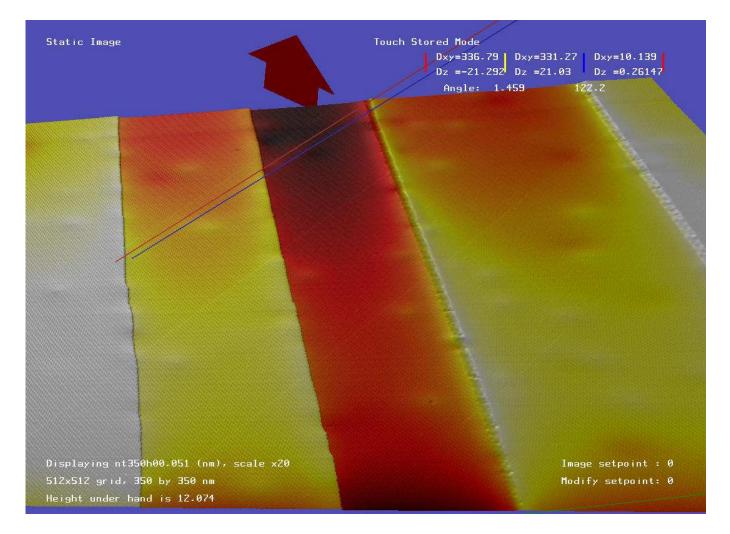


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Tungsten surface as used for our tests with surface steps and some Fe adsorbat Atoms. The step highlighted by the red and blue line denotes a monolayer step.

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# Segmentation/Labelling

Robust automatic segmentation/labelling of atoms and molecules:

- Segmentation:
  - several types of adsorbat atoms
  - STM topographic data
  - on-demand local spectroscopy
  - structural and statistical methods
- Labelling:
  - atoms: on/beneath the surface
  - molecules: orientation, shape descriptors



# Navigation/Calibration

- Navigation/Positioning
  - based on results of image processing
  - specialized software-controller
  - off-line training
- Calibration
  - consecutive update and recalibration of internal control
  - Calibrated Synthetic Viewing (CSV) approach
- Drift compensation
  - Kalman filtering
  - restrictive local scan approach



## **Manipulation Skills**

Hierarchical sensor-based skill library:

- basic skills
  - positioning tool tip
  - moving tool tip
  - pure pushing, pure pulling
  - attain/reattain adsorbat
- advanced skills (composed of basic and acvanced skills)
  - moving (attractive | repulsive | vertical)
  - collision-free path control
  - cleaning area



# **Planning/Simulation**

- Planning
  - rule-based planning
  - knowledge base with a set of rules for every adsorbat
  - error recovery for uncertainty
- Simulation
  - validating the moves of a path
  - validating the sequence of paths
- Control scheme
  - adjustable autonomy

## Outlook

- realized combination of nanoManipulator and UHV LT-STM not only an excellent platform for AMASH but also eases the usage of the STM
- step by step refinement towards automation
- a working system at every stage of development

